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**SCULLY, SCOTT, MURPHY
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To:	Examiner George P. Wyszomierski Art Unit: 1742	From:	Leslie S. Szivos
Fax:	571-273-8300	Pages:	14 pages including fax cover sheet
Phone:		Date:	11/21/2005
Re:	U.S. Patent Appln. No. 10/662,028 Docket: YOR920030203US1 (16694) Confirmation No. 9297	CC:	

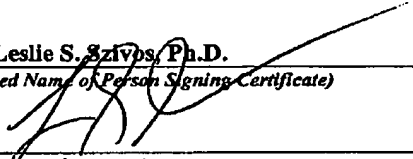
RESPONSE TO OFFICE ACTION

Please see the following documents:

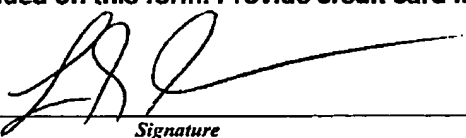
1. Amendment Transmittal (in duplicate)
2. Authorization to charge IBM deposit account
3. Response under 37 C.F.R. § 1.111
4. Certificate of transmission by facsimile dated November 21, 2005

If you have any questions concerning this facsimile please contact Vivian Henriquez at 516-742-4343.
Thank you.

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CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8) Applicant(s): Stephen W. Bedell et al.			Docket No. YOR920030203US1 (16694)	
Application No. 10/662,028	Filing Date September 12, 2003	Examiner George P. Wyszomierski	Group Art Unit 1742	
Invention: FORMATION OF A SILICON GERMANIUM-ON-INSULATOR STRUCTURE BY OXIDATION BURIED POROUS SILICON LAYER (As Amended)				
<p>I hereby certify that this <u>Response Under 37 C.F.R. § 1.111</u> (Identify type of correspondence)</p> <p>is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>571-273-8300</u>)</p> <p>on <u>November 21, 2005</u> (Date)</p> <p style="text-align: right;"><u>Leslie S. Szivos, Ph.D.</u> (Typed or Printed Name of Person Signing Certificate)</p> <p style="text-align: right;"> (Signature)</p>				
Note: Each paper must have its own certificate of mailing.				

P18/REV02

AMENDMENT TRANSMITTAL LETTER (Large Entity)					Docket No. YOR920030203US1 (16694)	
Applicant(s): Stephen W. Bedell et al.						
Application No. 10/662,028	Filing Date September 12, 2003	Examiner George P. Wyszomierski	Customer No. 23389	Group Art Unit 1742	Confirmation No. 9297	
Invention: FORMATION OF A SILICON GERMANIUM-ON-INSULATOR STRUCTURE BY OXIDATION OF A BURIED POROUS SILICON LAYER (As Amended)						
COMMISSIONER FOR PATENTS:						
Transmitted herewith is an amendment in the above-identified application.						
The fee has been calculated and is transmitted as shown below.						
CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	36 -	36 =	0	x \$50.00	\$0.00	
INDEP. CLAIMS	2 -	3 =	0	x \$200.00	\$0.00	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00	
<input checked="" type="checkbox"/> No additional fee is required for amendment. <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____ <input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed. <input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM <input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16. <input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17. <input type="checkbox"/> Payment by credit card. Form PTO-2038.						
WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.						
 Signature			Dated: November 21, 2005			
Leslie S. Szivos, Ph.D. Registration No. 39,394 SCULLY, SCOTT, MURPHY & PRESSER 400 Garden City Plaza - Suite 300 Garden City, New York 11530			<div style="border: 1px solid black; padding: 5px;"> I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on _____ (Date) _____ Signature of Person Mailing Correspondence _____ Typed or Printed Name of Person Mailing Correspondence </div>			
CC:						

P11LARGE/REV09

AMENDMENT TRANSMITTAL LETTER (Large Entity)				Docket No. YOR920030203US1 (16694)	
Applicant(s): Stephen W. Bedell et al.					
Application No. 10/662,028	Filing Date September 12, 2003	Examiner George P. Wyszomierski	Customer No. 23389	Group Art Unit 1742	Confirmation No. 9297
Invention: FORMATION OF A SILICON GERMANIUM-ON-INSULATOR STRUCTURE BY OXIDATION OF A BURIED POROUS SILICON LAYER (As Amended)					
COMMISSIONER FOR PATENTS:					
Transmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	36 -	36 =	0	x \$50.00	\$0.00
INDEP. CLAIMS	2 -	3 =	0	x \$200.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00
<input checked="" type="checkbox"/> No additional fee is required for amendment. <input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____ <input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed. <input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM <input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16. <input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17. <input type="checkbox"/> Payment by credit card. Form PTO-2038. WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.					
<i>Signature</i>			Dated: November 21, 2005		
Leslie S. Szivos, Ph.D. Registration No. 39,394 SCULLY, SCOTT, MURPHY & PRESSER 400 Garden City Plaza - Suite 300 Garden City, New York 11530			<div style="border:1px solid black; padding:5px;"><p>I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on _____</p><p style="text-align:center">(Date)</p><p style="text-align:center">_____ <i>Signature of Person Mailing Correspondence</i></p><p style="text-align:center">_____ <i>Typed or Printed Name of Person Mailing Correspondence</i></p></div>		
CC:					

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**Applicants:** Stephen W. Bedell, et al.**Examiner:** George P. Wyszomierski**Serial No.:** 10/662,028**Art Unit:** 1742**Filed:** September 12, 2003**Docket:** YOR920030203US1 (16694)**For:** FORMATION OF A SILICON
GERMANIUM-ON-INSULATOR
STRUCTURE BY OXIDATION OF A
BURIED POROUS SILICON LAYER
(As Amended)**Date:** November 21, 2005**Confirmation No:** 9297Mailstop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450**RESPONSE UNDER 37 C.F.R. § 1.111**

Sir:

In response to the Office Action dated August 24, 2005, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this document is being filed in the United States Patent and Trademark Office on the date shown below via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450 at United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

Dated: November 21, 2005
Leslie S. Szivos, Ph.D.

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